

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Kenshi FUKUMITSU et al.)	
Application No.: 10/571,142)	Confirmation No.: 3680
Filed: March 9, 2006)	Group Art Unit: 2829
For: SEMICONDUCTOR SUBSTRATE)	Examiner: Daniel B. Whalen
CUTTING METHOD)	

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Alexandria, VA 22314

Sir:

AMENDMENT

In response to the Office Action dated July 29, 2008, the period for response to which runs through January 29, 2009 by the concurrently-filed petition for a three-month extension of time and corresponding fee payment, please amend the above-identified application as follows.